

Supporting Information for RSC Advances

Multifunctional reversibly sealable microfluidic devices for patterned material deposition approaches

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Supporting Information

Figure S1

PDMS device fabrication in pictures – photographs on the left hand side and according schematic drawings on the right hand side. Including one fluorescence microscopy image obtained while utilizing the four-channel PDMS stamp produced during the photo series.

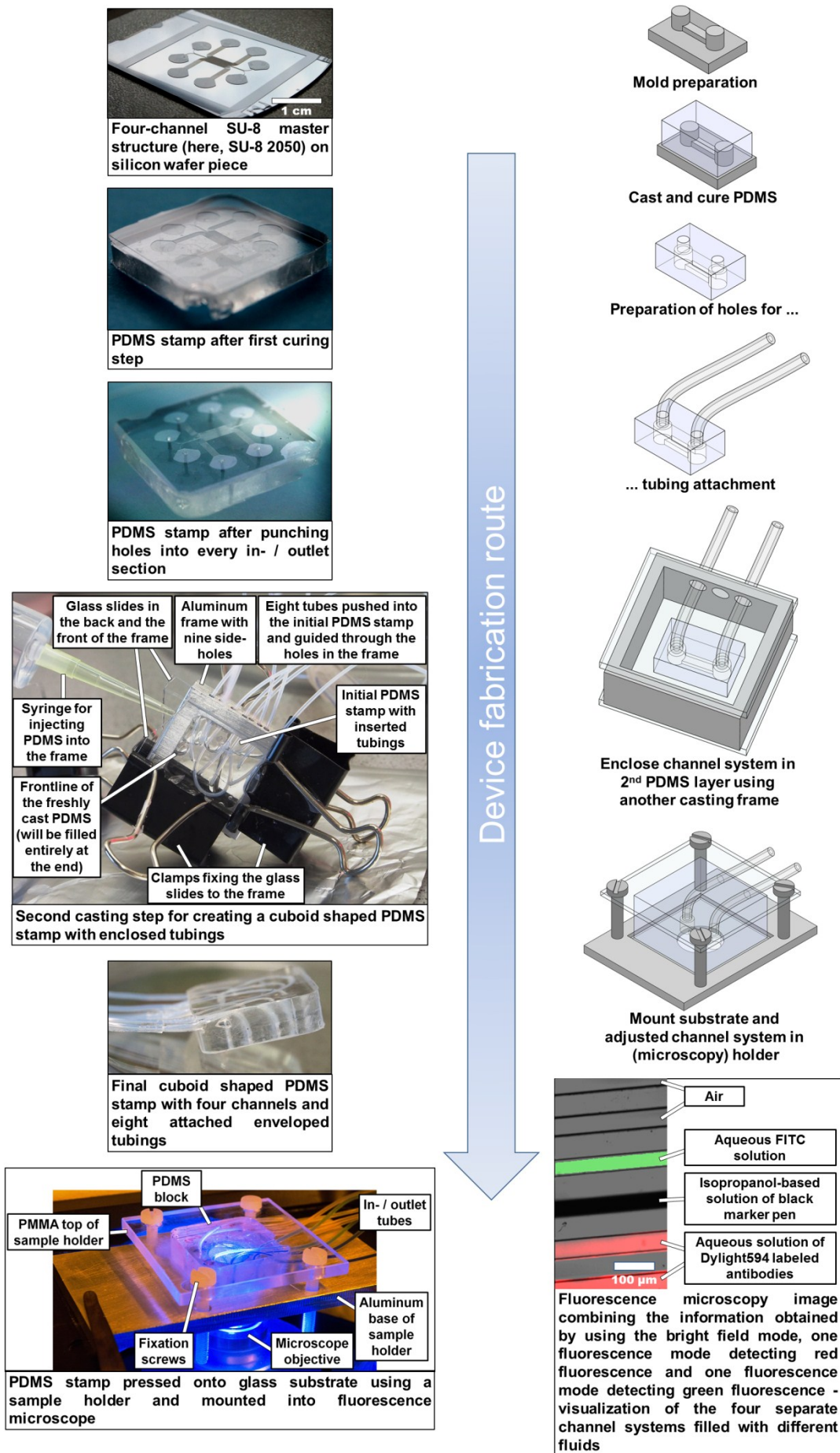


Figure S1